

<b>Notice of References Cited</b>	Application/Control No. 10/527,775	Applicant(s)/Patent Under Reexamination VAN BEZOOIJEN ET AL.	
	Examiner Richard Chan	Art Unit 2618	Page 1 of 1

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*	C	US-6,678,507	01-2004	Kurokawa et al.	455/127.1
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*	E	US-6,725,027	04-2004	Tsuji et al.	455/296
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	K	US-			
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	M	US-			

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**NON-PATENT DOCUMENTS**

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